A METAMATERIAL BASED MICROWAVE ABSORBER COMPOSED OF COPLANAR ELECTRIC-FIELD-COUP-LED RESONATOR AND WIRE ARRAY

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Abstract—In this paper, we present a new type of a double-negative metamaterial absorber (MMA) with a periodic array composed of in-plane an electric-field-coupled-LC (ELC) resonator and a wire. In contrast to common MMA configurations, a metallic pattern layer of the proposed absorber is placed parallel to the incident wave propagation direction. An appropriately designed combination structure is etched on one side of an FR-4 substrate. Here, we fabricated a prototype absorber with a planar array of 66×30 unit cells. Our experiments showed that the proposed absorber exhibited a peak absorption rate greater than 86% at 10.1 GHz irrespective of the incident angles up to 60° .

1. INTRODUCTION

Microwave absorbers are used in military applications to reduce the radar cross-section (RCS) of a conducting object and the electromagnetic (EM) interference among microwave components. One of the earliest approaches for the design of EM absorber structures was based on the use of a Salisbury screen [1]. This type of absorber includes a resistive sheet and a metallic ground plane to cancel out reflections from the screen. Recently, the absorber technology has seen several advancements in the use of artificially structured metamaterials (MTMs) for the microwave terahertz, infrared, and optical frequency regimes [2–5]. Additionally, much works has done in integrating MMAs into creating novel devices applications [6–9]. Compared to the traditional microwave absorber, the thickness of resonant MMA can be much thinner, and the fabrications of MMA are low cost and

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simple. It should be noted that most of the MMAs, to avoid power transmission on the other side of the absorber, are equipped with a metallic backing plate [10–14]; however, the presence of backing plates may be disadvantageous in stealth applications [15]. The configuration of the previously reported metallic backplane-less MMAs involves the realization of both the metallic pattern with the negative real part of the permittivity and permeability. The two metallic pattern layers separated by a dielectric spacer are placed orthogonal to the electromagnetic (EM) wave propagation direction [16–20]. In the case where these layers are orthogonal to the EM wave propagation direction, the RCS of the metallic pattern may increase at frequencies other than the frequency bands targeted. Therefore, to avoid this problem, the metallic pattern laver should be placed parallel to the EM wave propagation direction. In this work, we present a new type of a double-negative MMA with a periodic array composed of an electricfield-coupled-LC (ELC) resonator and a wire in the same plane. In contrast to common absorber configurations, a metallic pattern layer of the absorber proposed in this paper is placed parallel to the incident wave propagation direction.

2. DOUBLE-NEGATIVE IN-PLANE MMA UNIT CELL DESIGN

The proposed configuration of the backplane-less absorber with doublenegative MTM unit cell structures is shown in Figure 1. In contrast to common absorber configurations, the absorber proposed in this study includes a metallic pattern laver etched on a dielectric substrate; this layer is placed parallel to the transverse electric (TE) polarized EM wave propagation direction, as shown in Figure 1(a). A single unit cell of the proposed absorber consists of distinct metallic elements, as shown in Figure 1(b). We created a double-negative MTM structure by combining an ELC resonator and a wire in the same plane. When a time-varying electric field, polarized in the direction normal to the capacitor plates of the ELC, is incident upon the MTM structure, an electric response is provided by the ELC resonator [21]. In the case where a magnetic field, polarized normal to the loops of the ELC resonator, is incident upon the MTM structure, anti-parallel surface currents are induced in both the wire and one metallic loop pattern of the ELC resonator, resulting in a magnetic response. The absorber unit cell is made with an FR-4 substrate, which has a relative dielectric constant ε_r of 4.6, a loss tangent δ of 0.025, and a thickness t of 1.0 mm. Copper, with a conductivity σ of 5.8×10^7 S/m, is used for the metallic patterns. The optimum geometrical dimensions of the proposed unit

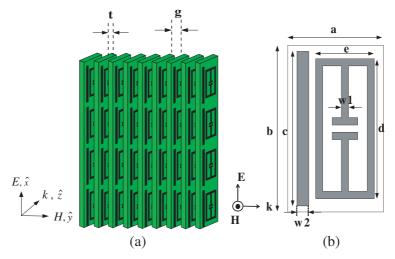


Figure 1. Sketch describing the structures of MTM absorber: (a) metallic patterns placed orthogonal to propagation direction and (b) layout of a single absorber unit cell.

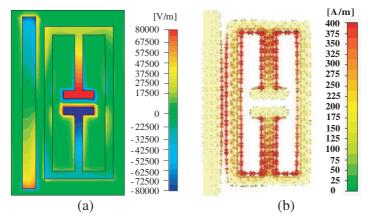


Figure 2. Simulated (a) electric field and (b) surface current distributions at resonant frequency.

cell are as follows: a = 4.1 mm, b = 6.7 mm, c = 6.3 mm, d = 5.7 mm, e = 2.5 mm, w1 = 0.3 mm, and w2 = 0.5 mm.

Computer simulations are carried out using the commercial solver Microwave Studio by CST. The program simulated a single unit cell with appropriate periodic boundary conditions. Figure 2 shows the simulated electric field distribution and the surface current distribution at the resonant frequency. As observed in Figure 2(a), the capacitive element in the ELC resonator and the vertical wire structure strongly couple with the electric field of the incident EM wave. The magnetic field component of the incident EM wave penetrates the MMA plane, which generates an anti-parallel surface current both of the wire and one metallic loop pattern of the ELC resonator, as shown in Figure 2(b). The scattering parameters of this MTM unit cell were simulated, and the absorption was calculated by the equation A = 1 - 1 $|S_{11}|^2 - |S_{21}|^2 = 1 - R(\omega) - T(\omega)$. Figure 3 shows the simulation results for the proposed MMA, by plotting the absorption $A(\omega)$, reflectance $R(\omega)$, and transmission $T(\omega)$. From this figure, it can be observed that the reflectance and transmission of the absorber sharply decrease to a minimum at a frequency of 9.95 GHz, with a peak absorption rate of 94%, which indicates strong absorption of the EM wave energy. In order to express the effective permittivity and permeability of the artificial material in terms of scattering parameters, this information is conventionally retrieved from the scattering parameters of the unit cell [22]. The extracted effective medium parameters of the proposed MMA over a frequency range of 9-11 GHz are plotted in Figures 4(a)-(c), and the values of the extracted effective medium parameters at $9.95 \,\mathrm{GHz}$ are listed in Figure 4(d). The real and imaginary components of ε_{eff} (= $\varepsilon' + j\varepsilon''$) and μ_{eff} (= $\mu' + j\mu''$) are plotted in Figure 4(a). Note that both the real components of the effective permittivity and permeability (ε' and μ') are negative and the imaginary components (ε'' and μ'') are positive, at 9.95 GHz. This meets the general condition for power flow and the phase velocity to be directed in opposite directions, which is written as $\varepsilon' \mu'' + \mu' \varepsilon'' < 0$ [23].

As a result, the proposed unit cell can be regarded as a doublenegative MTM unit cell. In Figure 4(c), the normalized impedance is near unity at a frequency of 9.95 GHz, this implies that the impedance

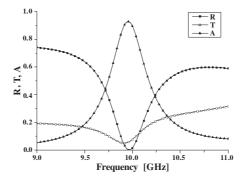


Figure 3. Simulation results for the MTM absorber: absorption $A(\omega)$, reflectance $R(\omega)$ and transmission $T(\omega)$.

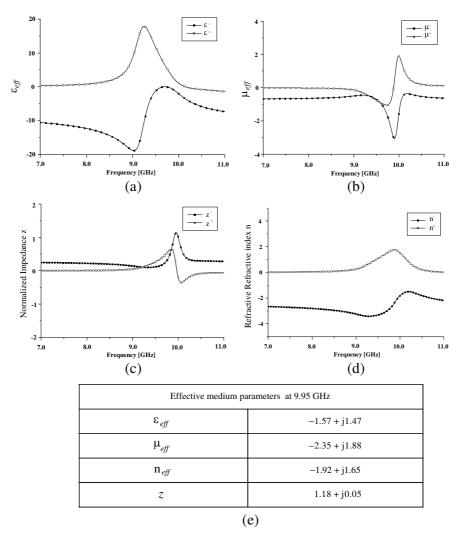


Figure 4. Extracted effective medium parameters: (a) effective permittivity ε_{eff} , (b) permeability μ_{eff} , (c) refractive index n_{eff} , (d) normalized intrinsic impedance z, and (e) summery.

of the proposed MTM unit cell is well matched to that of free space. As shown in Figure 4(d), the imaginary part of the refractive index (n'')is 1.65 in the left-handed frequency region which means absorption of the EM wave energy. The characteristic of this absorption can be understood from Figure 5, which shows the simulated distribution of the average power loss densities in the absorber unit cell at the peak

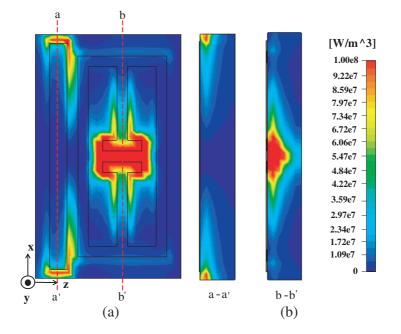


Figure 5. (a) Distributions of average power loss density in absorber plane (zx-plane), and (b) in each vertical cutting plane (yx-plane).

absorption frequency of 9.95 GHz. It should be noted that power loss mainly occurs in the space neighboring the capacitor plates of the ELC resonator and near the two outer edges of the metal wire, as shown in Figure 5(a). The simulated peak absorption curve as a function of different incident angles for the transverse electric (TE) and transverse magnetic (TM) polarizations of the EM waves is plotted in Figure 6. The absorption curve for different incident angles of the EM waves over a broad frequency range from 9 to 11 GHz is also given in the inset of the Figure 6. For the TE polarization case, as the incidence angles increase, the peak absorption remains at 94% at an angle of 60°, and then, it decreases to 30% at 75°. As the incidence angle angles increase, the overall peak absorption decreases for the TM polarization case. At the incident angle of 45°, there is a dip of the peak absorption rate of 84%.

Both the TE and TM polarization, the peak absorption decreases significantly at the incident angle of 75°. This decrease in the absorption can be explained on the basis of the fact that the incident magnetic field can no longer effectively drive the circulating currents between two metallic patterns.

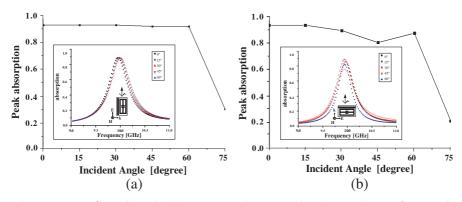


Figure 6. Simulated oblique incident angle dependence for peak absorption for (a) TE and (b) TM incidence.

3. EXPERIMENTAL RESULT

We fabricated a prototype absorber for experimentation. The photographs of the fabricated single-layer metallization MTM absorber and the single absorber strip sample are shown in Figure 7. The sample was etched on an FR-4 substrate (with a relative dielectric constant ε_r of 4.6, loss tangent δ of 0.025, and thickness t of 1.0 mm) using standard photolithography techniques. In order to verify the effectiveness of the double-negative MTM absorber cells without a metallic backing plate, a planar array of absorber unit cells (66×30) was mounted on an acryl substrate frame. One period of the absorber strip consists of 30 unit cells etched on one side of an FR-4 substrate. The fabricated prototype absorber comprises a stacked array of absorber strips. A polystyrene foam substrate with a relative permittivity of 1.02 is inserted between the absorber strips. Single absorber strips made with an ELC resonator and a wire configuration are aligned vertically parallel to the wave The inter-element spacing between the two propagation direction. vertically aligned absorber strips was set to 2 mm, and the total size of the planar absorber was 200×201 mm. We experimentally verified the behavior of the absorber by measuring the S-parameters of a planar array of unit cells. Measurements were performed over a frequency range of 9–11 GHz using a vector network analyzer and two X-band microwave horn antennas. To test the absorption properties for oblique incidence angles, two rectangular horn antennas were focused on the sample sheet on the same side and the sample absorber sheet was rotated from 0° to 60° in steps of 15° .

The frequency-dependent absorption calculated using the measured magnitudes of the S_{11} and S_{21} parameters for the planar arrayed unit cells. The measured peak absorption curve as a function of

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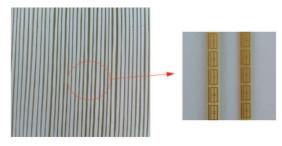


Figure 7. Photographs of the fabricated prototype absorber with the stacked array of absorber strips.

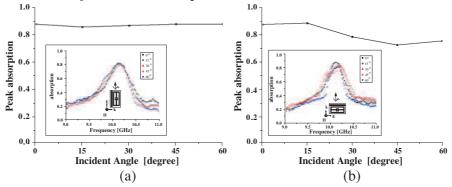


Figure 8. Measured oblique incident angle dependence for peak absorption for (a) TE and (b) TM incidence.

different incident angles for the TE and TM polarizations of the EM waves is plotted in Figure 8. The results show that the overall peak absorption slightly decreases for both TE and TM polarizations, and the experimental center frequencies of the peak absorption are shifted by approximately 18 MHz as compared to the simulated results. In addition, with regard to the proposed absorber, the peak absorption rate remains above 86% (for TE case) and 74% (for TM case), irrespective of the incident angles up to 60° .

4. CONCLUSIONS

In this study, we proposed a new type of a backplane-less MMA configuration. A metallic pattern layer of the proposed absorber is placed parallel to the incident wave propagation direction. Further, we showed that appropriately planar arrayed single unit cells with an ELC resonator and a wire configuration can effectively absorb most of the incident power. The main advantage of the proposed

absorber is the reduction of the RCS due to a metallic back plate or metallic patterns for a MMA, at frequencies other than the absorption frequency bands. The size of the miniaturized MTM absorber unit cell was $4.1 \times 6.7 \times 1$ mm. We fabricated a prototype absorber with a planar array of 66×30 unit cells, and experimentally verified the performance of the proposed absorber. From the results of our study, we found that the design of the proposed absorber configuration can be easily extended to the design of more compact, thinner backplane-less planar absorbers for millimeter and terahertz frequency applications.

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